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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOSHIHIRO ISHIDA ET AL.

Application No.: 09/164,624

Filed: October 1, 1998

For: MONITORING SYSTEM
APPARATUS AND PROCESSING
METHOD

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:
) Examiner: Lin Ye
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) Group Art Unit: 2612
:
) Confirmation No.: 6892
:
)
:
) July 2, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed, together with a copy of a Japanese Official Action citing them, and a translation of that Action.

For the concise explanation of relevance for the non-English documents, the Examiner is referred to the accompanying English abstracts.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

July 2, 2004
(Date of Deposit)

LEONARD P. DIANA (Reg. No. 29,296)
(Name of Attorney for Applicant)

Leonard P. Diana
Signature

July 2, 2004
Date of Signature

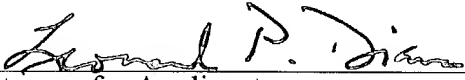
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CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
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